MICRON.250C1 PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants

Li, et al.

Group Art Unit Unknown

Appl. No.

Unknown

Filed

Herewith

For

ELIMINATION OF DENDRITE

FORMATION DURING METAL / CHALCOGENIDE GLASS

DEPOSITION

Examiner

Unknown

## PRELIMINARY REMARKS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Applicants submit this Preliminary Remarks paper in the present continuation application in response to an Office Action mailed March 19, 2003, in connection with U.S. Patent Application No. 10/164,646, filed June 6, 2002, which is the parent application to the present continuation application.

Claims 1-14 of the present continuation application correspond to original Claims 1-13 and 19 of the parent application. Claim 15 of the present continuation application is new.